

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Den Toonder, *et al.*

Docket No.: EPC-018

Serial No.: 10/578,027

Art Unit: 1733

Filed: November 6, 2008

Examiner: Janell Combs Morillo

For: Radio-Frequency Microelectromechanical Systems and a Method of
Manufacturing Such Systems

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed December 23, 2010. Please amend the above-referenced application as follows.